

APPLICATION DATA SHEET

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*Applicant Information:*Inventor 1:

Applicant Authority Type:	Inventor
Citizenship:	JP
Given Name:	Shinji
Family Name:	MAEKAWA
City of Residence:	Iwata, Shizuoka
Country of Residence:	JP
Address-1 of Mailing Address:	3-12-3, Toushin-cyo,
Address-2 of Mailing Address:	
City of Mailing Address:	Iwata-shi, Shizuoka-ken
State of Mailing Address:	
Postal Code of Mailing Address:	438-0039
Country of Mailing Address:	JP
Phone:	
Fax:	
E-mail:	

Inventor 2:

Applicant Authority Type:	Inventor
Citizenship:	JP
Given Name:	Shunpei
Family Name:	YAMAZAKI
City of Residence:	Setagaya, Tokyo
Country of Residence:	JP
Address-1 of Mailing Address:	c/o Semiconductor Energy Laboratory Co., Ltd.
Address-2 of Mailing Address:	398, Hase,
City of Mailing Address:	Atsugi-shi, Kanagawa-ken
State of Mailing Address:	
Postal Code of Mailing Address:	243-0036
Country of Mailing Address:	JP
Phone:	
Fax:	
E-mail:	

Inventor 3:

Applicant Authority Type: Inventor
Citizenship: JP
Given Name: Yuko
Family Name: TACHIMURA
City of Residence: Atsugi, Kanagawa
Country of Residence: JP
Address-1 of Mailing Address: c/o Semiconductor Energy Laboratory Co., Ltd.
Address-2 of Mailing Address: 398, Hase,
City of Mailing Address: Atsugi-shi, Kanagawa-ken
State of Mailing Address:
Postal Code of Mailing Address: 243-0036
Country of Mailing Address: JP
Phone:
Fax:
E-mail:

Inventor 4:

Applicant Authority Type: Inventor
Citizenship: JP
Given Name: Koji
Family Name: MURANAKA
City of Residence: Kumamoto, Kumamoto
Country of Residence: JP
Address-1 of Mailing Address: 4-33, Idenakama,
Address-2 of Mailing Address:
City of Mailing Address: Kumamoto-shi, Kumamoto-ken
State of Mailing Address:
Postal Code of Mailing Address: 862-0963
Country of Mailing Address: JP
Phone:
Fax:
E-mail:

Correspondence Information:

Customer Number: 22204 *22204*

Application Information:

Title of Invention: METHOD FOR FORMING WIRING, METHOD FOR
MANUFACTURING THIN FILM TRANSISTOR OR AND
DROPLET DISCHARGING METHOD

Application Type: regular, utility

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as our attorney(s) or agent(s) to prosecute the application identified above, and to
transact all business in the United States Patent and Trademark Office connected
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*Assignee Information:*Assignee 1:

Organization Name: Semiconductor Energy Laboratory Co., Ltd.

Address-1 of Mailing Address: 398, Hase,

Address-2 of Mailing Address:

City of Mailing Address: Atsugi-shi, Kanagawa-ken

State of Mailing Address:

Postal Code of Mailing Address: 243-0036

Country of Mailing Address: JP

Phone:

Fax:

E-mail: